



PATENT
Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Gaku MINAMIHABA et al.) Group Art Unit: 2818
)
Application No. 10/771,060) Examiner: Goodwin, David J.
)
Filed: February 4, 2004) Confirmation No.: 2231
)
For: POLISHING PAD AND METHOD OF)
MANUFACTURING)
SEMICONDUCTOR DEVICES)

Mailstop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed January 23, 2007, the period for response to which having been extended to May 23, 2007, by a Petition for Extension of Time of one month and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.